

VANDERBILT
SCHOOL OF ENGINEERING

Georgia Institute
of Technology



Heavy Ion Current Transients in SiGe HBTs

Jonathan A. Pellish¹, R. A. Reed², G. Vizkelethy³, D. McMorrow⁴, V. Ferlet-Cavrois⁵, J. Baggio⁵, P. Paillet⁵, O. Duhamel⁵, S. D. Phillips⁶, A. K. Sutton⁶, R. M. Diestelhorst⁶, J. D. Cressler⁶, P. E. Dodd³, M. L. Alles², R. D. Schrimpf², P. W. Marshall⁷, and K. A. LaBel¹

¹: Radiation Effects and Analysis Group, NASA/GSFC Code 561.4, Greenbelt, MD 20771

²: Department of Electrical Engineering and Computer Science, Vanderbilt University, Nashville, TN 37235

³: Sandia National Laboratories, Albuquerque, NM 87175

⁴: Naval Research Laboratory, Washington, DC 20375

⁵: The CEA, DAM, DIF, F-91297 Arpajon, France

⁶: School of Electrical and Computer Engineering, Georgia Institute of Technology, Atlanta, GA 30332

⁷: NASA Consultant, Brookneal, VA 25428

Sandia is a multiprogram laboratory operated by Sandia Corporation, a Lockheed Martin Company, for the United States Department of Energy's National Nuclear Security Administration under Contract DE-AC04 94AL85000.

Overview

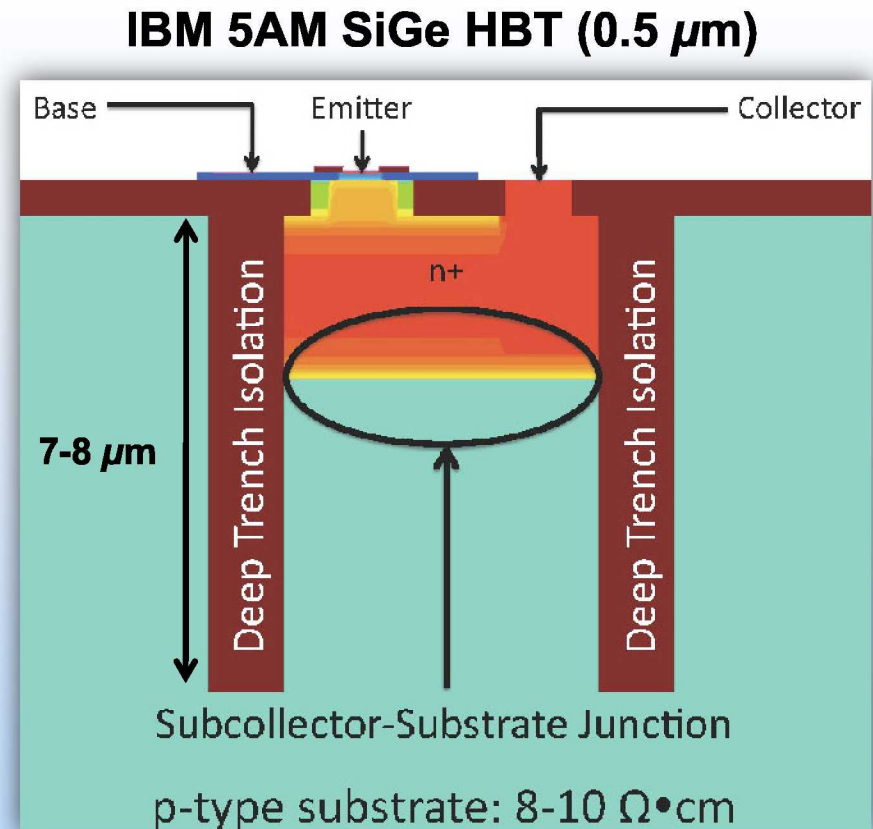


- **Look at device under test (IBM 5AM SiGe HBT)**
- **Review bias conditions of interest**
 - **Relation to findings of previous experiments**
- **Heavy ion microbeam data**
 - **36 MeV ^{16}O (SNL)**
- **Heavy ion broadbeam data**
 - **Low- and high-energy tunes (JYFL and GANIL)**
- **Path forward and summary**

Device Background and Introduction



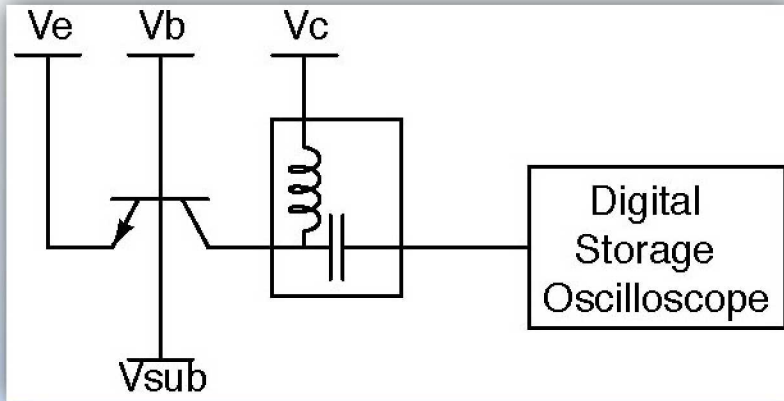
- **Key device characteristics**
 - Deep trench isolation
 - Subcollector junction
 - Lightly-doped p-type substrate (large)
- **Extend state-of-the-art knowledge**
 - Move beyond charge collection



J. A. Pellish *et al.*, *IEEE Trans. Nucl. Sci.*, vol. 55, no. 6, p. 2936, Dec. 2008.

Previous measurements on SiGe HBTs have only looked at laser-induced transients or heavy ion charge collection.

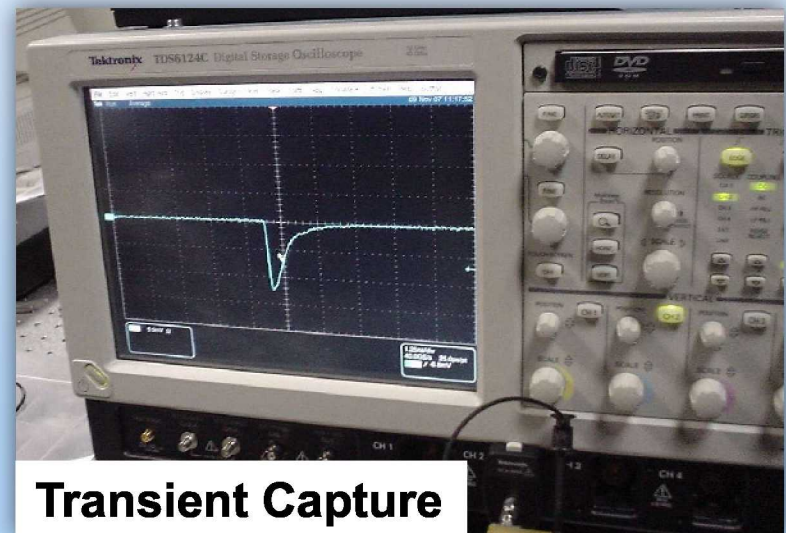
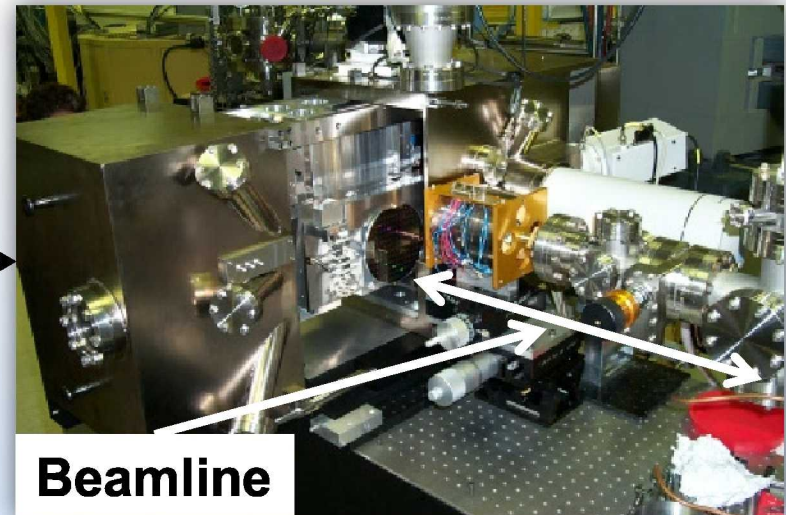
Microbeam Experimental Setup



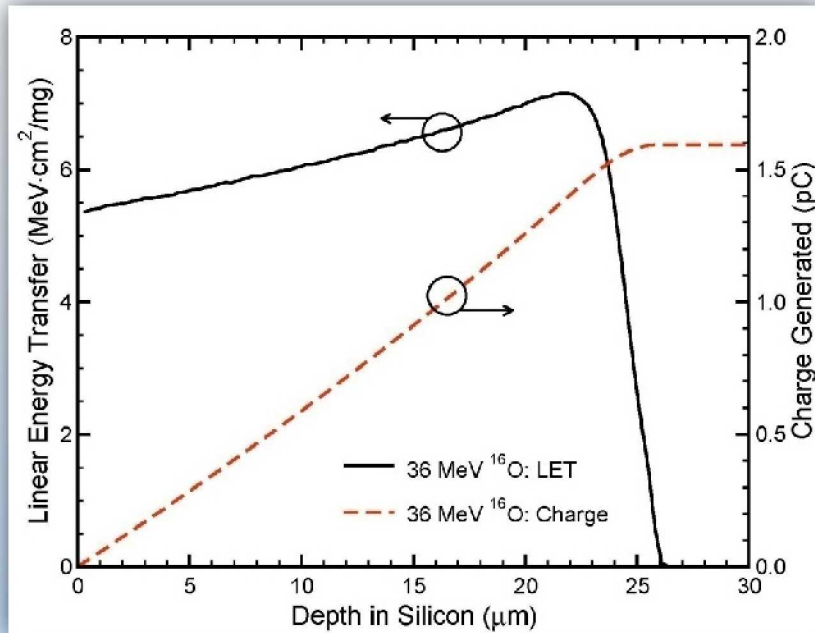
Similar setup for 4-terminal measurements

- PSPL Bias Tees: 5542K
- DPO/DSO: Tek 71604A (16 GHz; 50 GS/s), Tek 72004A (20 GHz; 50 GS/s)
- 2.9 mm coaxial cable assemblies (40 GHz)

**Sandia National Laboratories'
Microbeam Chamber**

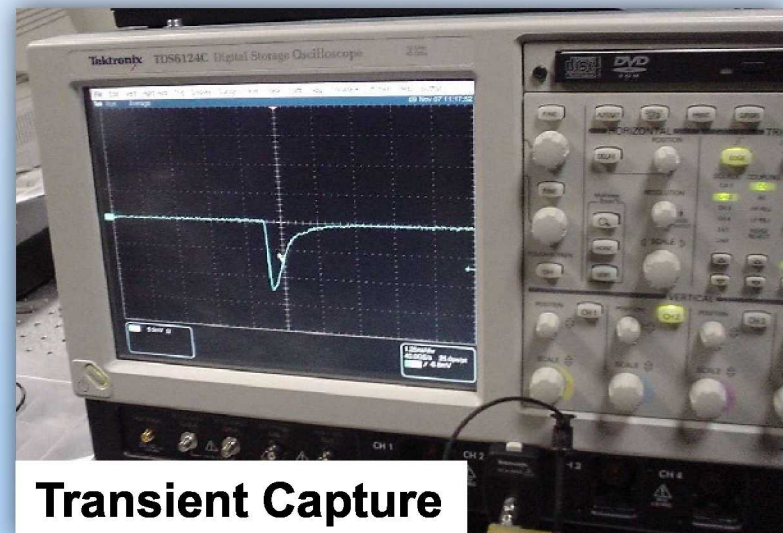


Microbeam Experimental Setup



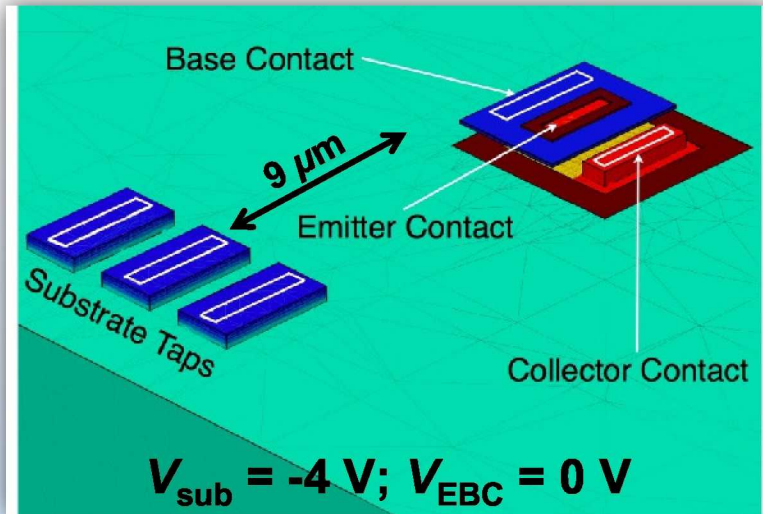
36 MeV ^{16}O dE/dx profile
[SRIM-2008]

Sandia National Laboratories'
Microbeam Chamber

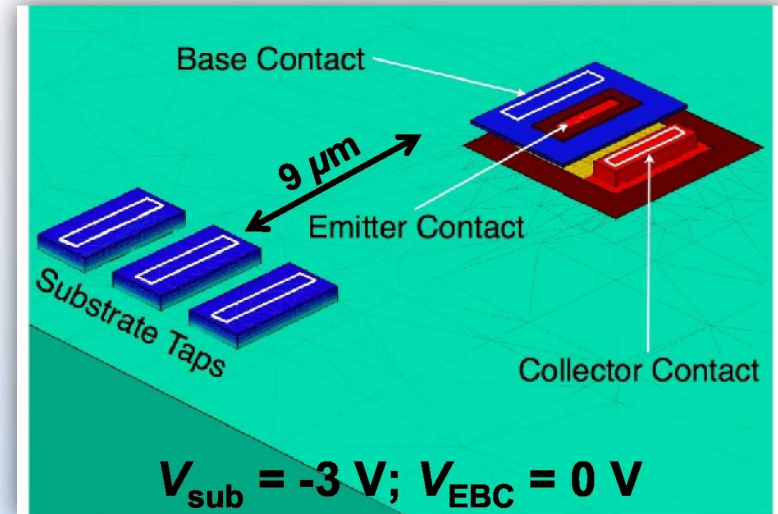


Bias Conditions of Interest

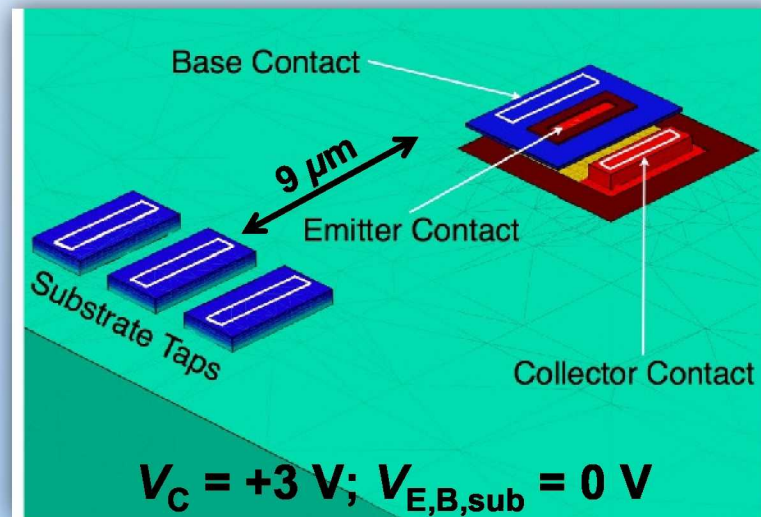
CASE 1



CASE 3



CASE 2

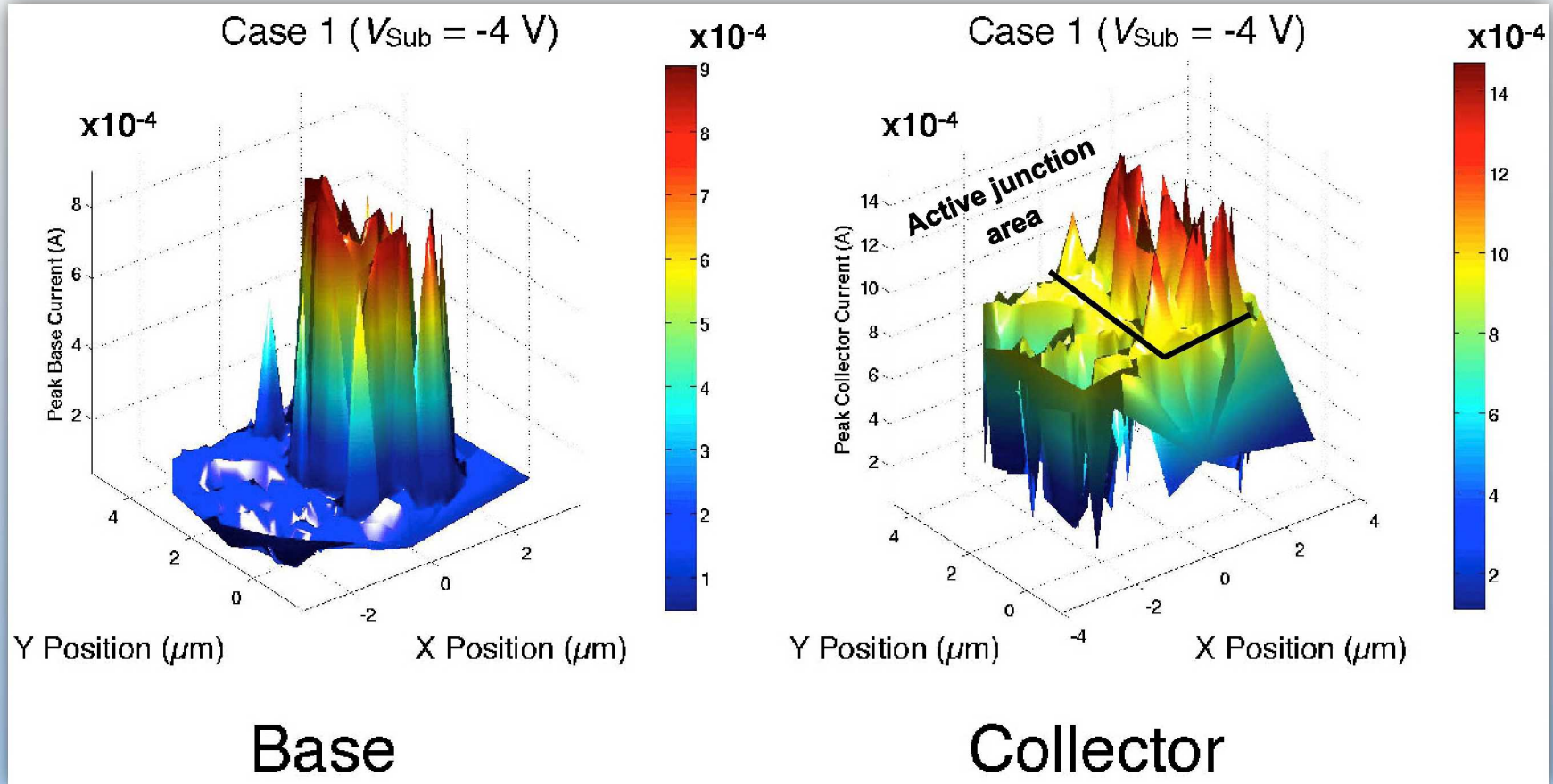


- 3-D TCAD
- Rendering from GDSII of actual DUTs

36 MeV ^{36}O Microbeam Data: Case 1



Peak Current Magnitude

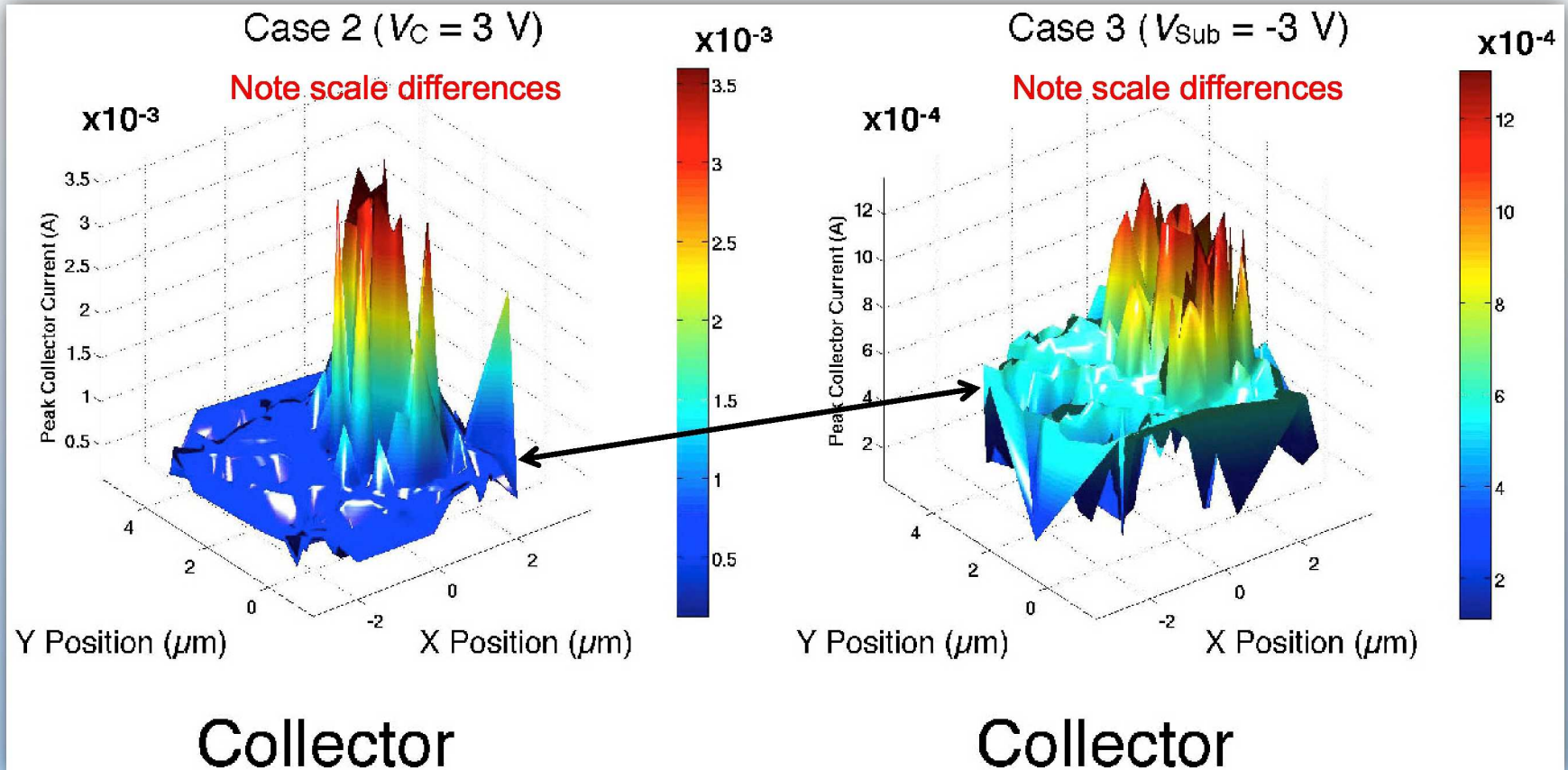


- Base terminal images base-collector junction
- Collector terminal images base-collector junction and subcollector

36 MeV ^{36}O Microbeam Data: Cases 2 & 3



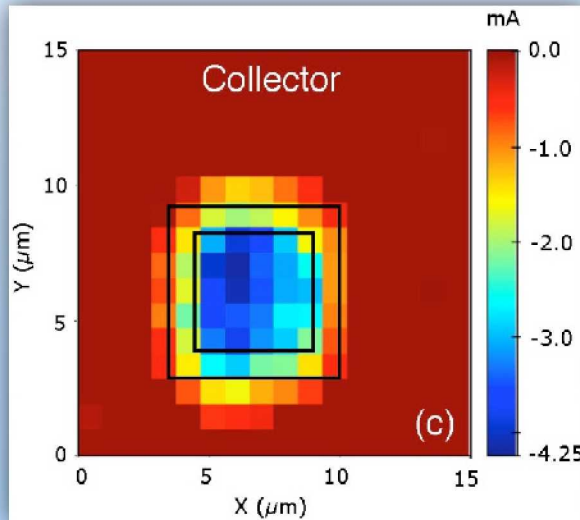
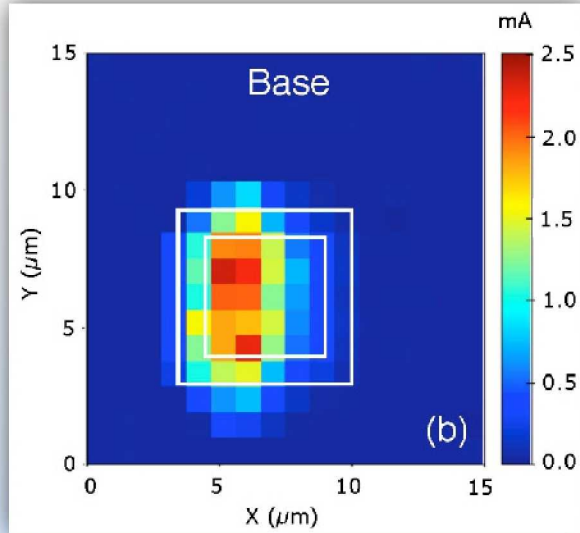
Peak Current Magnitude



- Significant current magnitude increase for $V_c = +3 \text{ V}$
- Observed in two-photon pulsed laser testing too

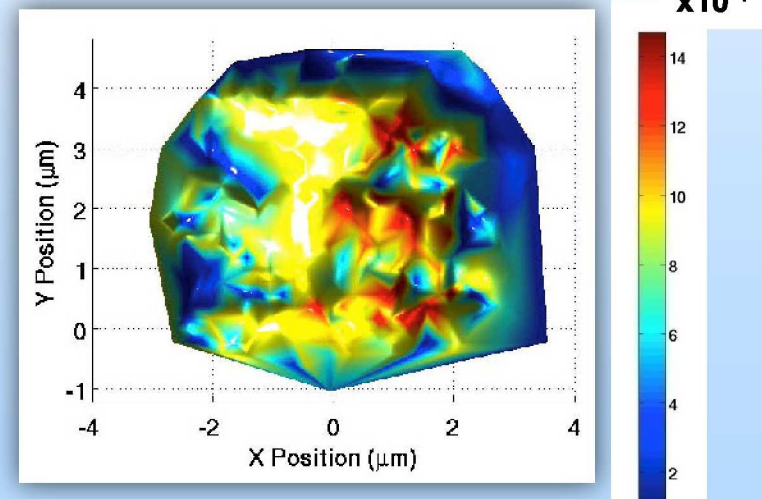
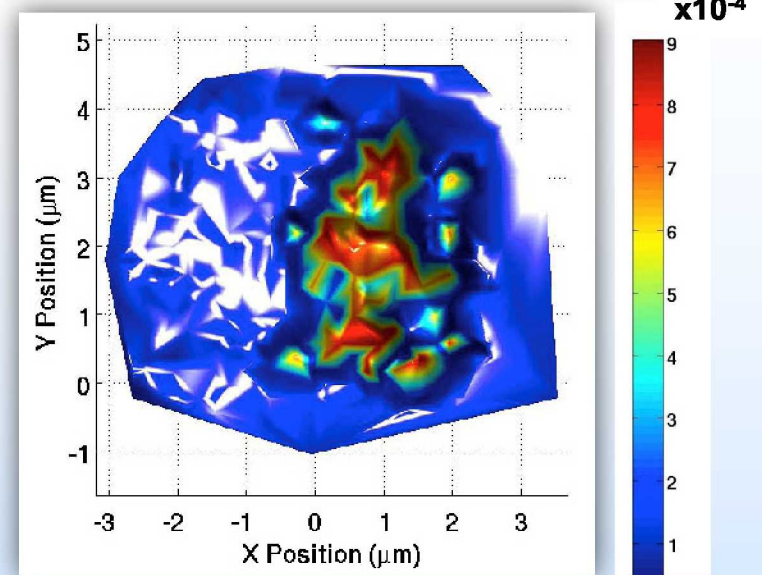
TPA Pulsed Laser vs. Microbeam

J. A. Pellish et al., *IEEE Trans. Nucl. Sci.*, vol. 55, no. 6, p. 2936, Dec. 2008.

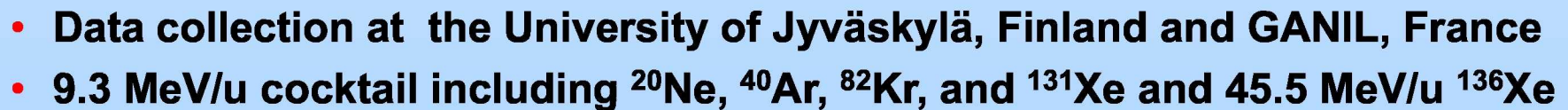


TPA Pulsed Laser

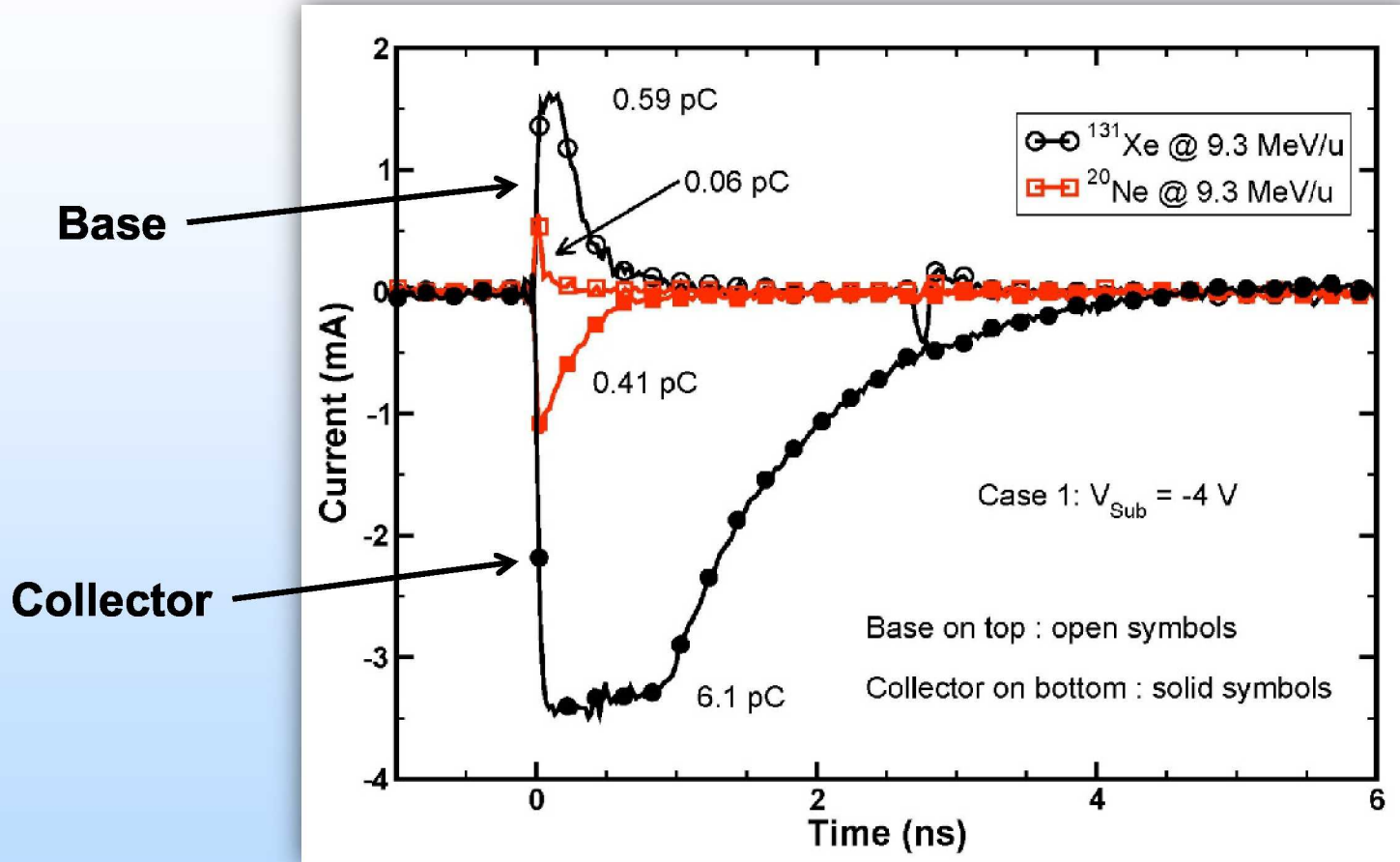
**Both data
sets for
CASE 1
($V_{\text{sub}} = -4 \text{ V}$)**



Microbeam



JYFL Broadbeam Transients

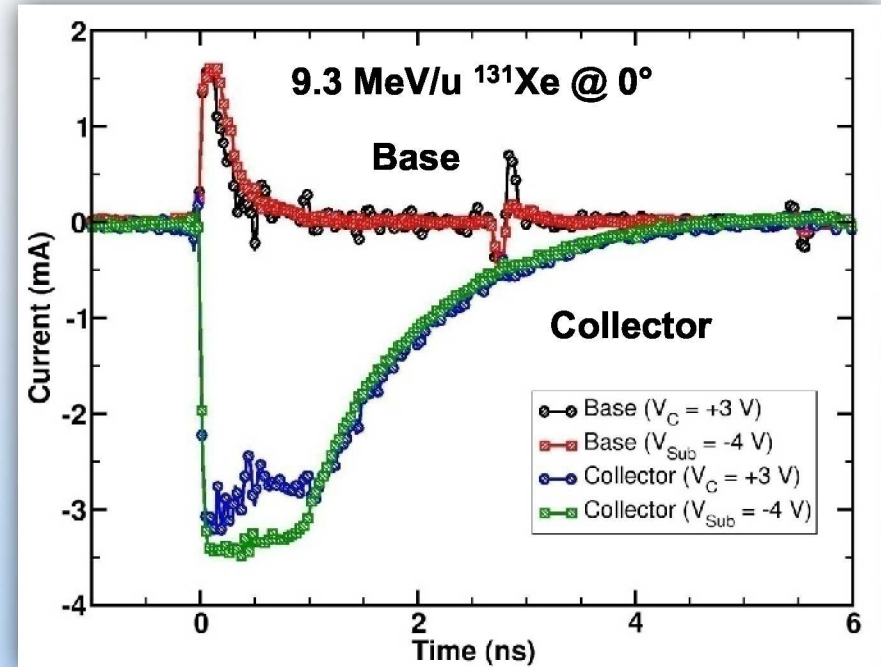
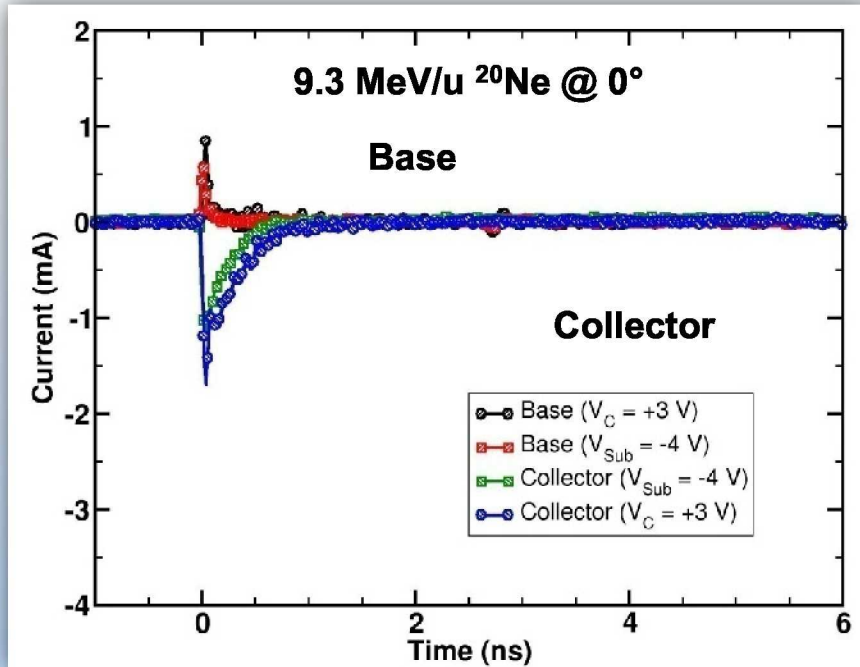


- Typical events observed from events somewhere within active region
- Position inferred using SNL microbeam data

JYFL Broadbeam Transients



Maximum amplitude transients as a function of bias

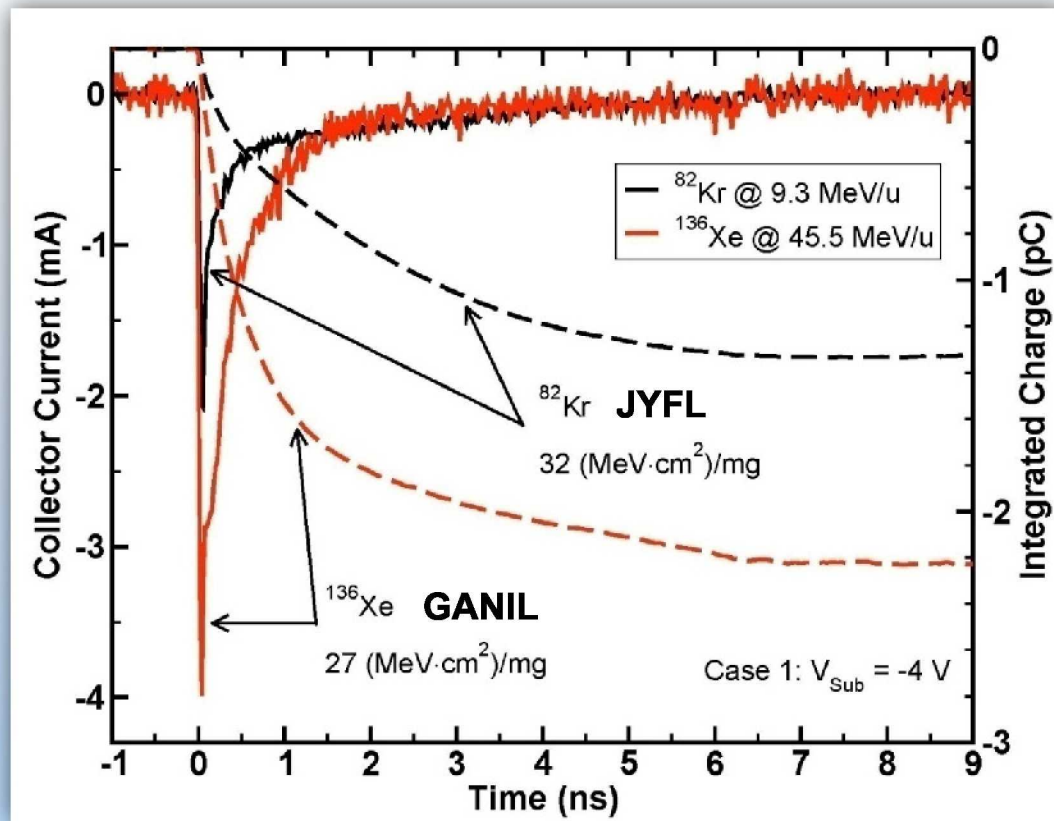


- Saturation of collector current transient with highly ionizing particle
- Some bias dependence, but masked by random hit location

JYFL vs. GANIL Broadbeam Transients



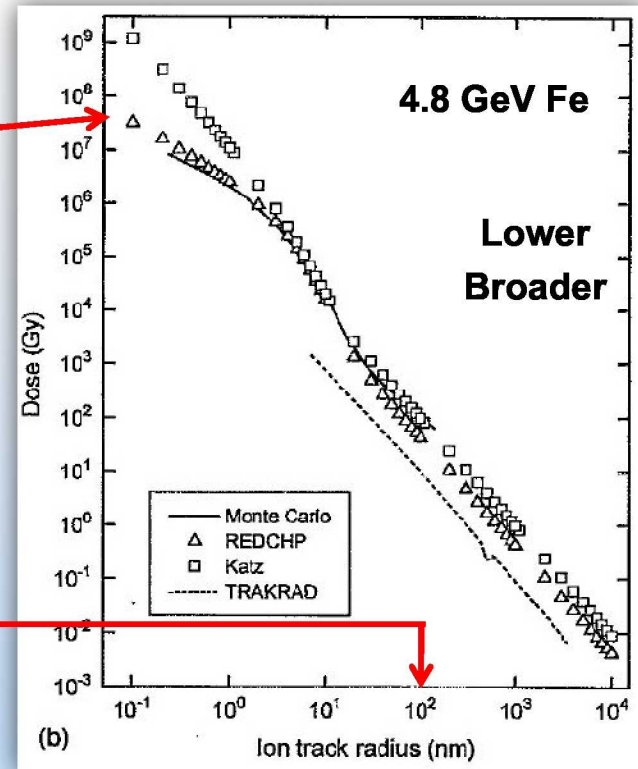
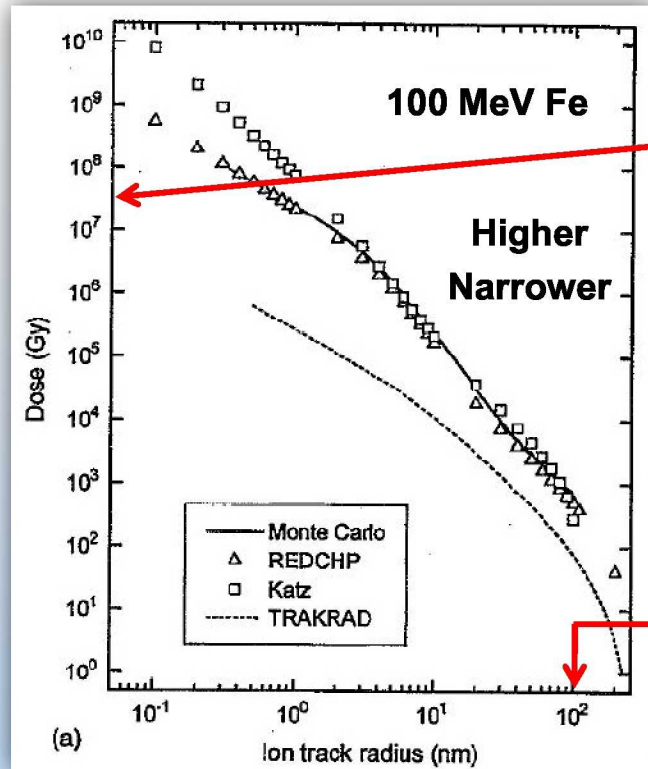
Ion
Range



Recombination

- Similar LET values produce different transient responses
- Trend holds for average of all transients for each LET

Influence of Ion Energy



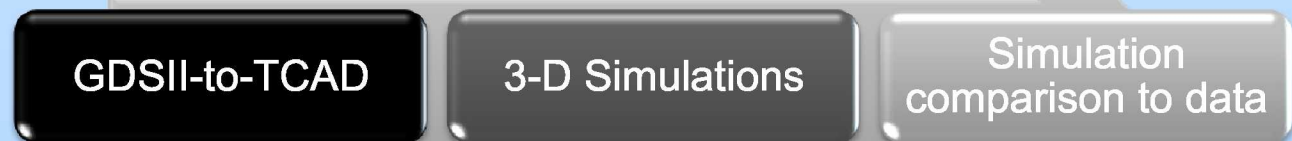
O. Fageeha *et al.*, *J. Appl. Phys.*, vol. 75, no. 5, p. 2317, Mar. 1994.

- **Ion energy determines δ -ray energy**
- **Higher energy ion reduces eh-plasma density**
 - **Ambipolar and bipolar transport affected by carrier density**
 - **Space charge screening effects**

Path Forward

- **Attempt to uncover reason for increase in collector current for $V_C = +3$ V bias condition**
 - Impact ionization or other positive feedback mechanism
- **Conduct simulation study to understand differences between microbeam and broadbeam data**
 - Alleviates some difficulties with modeling TPA data
- **Uncover role of ion range and recombination mechanisms in lightly-doped substrates**
 - GANIL 45.5 MeV/u ^{136}Xe vs. JYFL 9.3 MeV/u ^{82}Kr

Order
of
Operations





Summary

- **Time-resolved ion beam induced charge reveals heavy ion response of IBM 5AM SiGe HBT**
 - Position correlation
 - Unique response for different bias schemes
 - Similarities to TPA pulsed-laser data
- **Heavy ion broadbeam transients provide more realistic device response**
 - Feedback using microbeam data
 - Overcome issues of LET and ion range with microbeam
- **Both micro- and broadbeam data sets yield valuable input for TCAD simulations**
 - Uncover detailed mechanisms for SiGe HBTs and other devices fabricated on lightly-doped substrates